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Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE <b>LIST OF ART CITED BY APPLICANT</b> (Use several sheets if necessary)					ATTY. DOCKET NO. 30-5000-(4015)-Div2	SERIAL NO. 09/784,233	
					APPLICANT Shozo Nagano et al.	#20	
					FILING DATE February 14, 2001	GROUP 1742	
<b>U.S. PATENT DOCUMENTS</b>							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
Z	AA	5,312,790	05-1994	Sengupta et al.	501	137	
	AB	5,435,826	07-1995	Sakakibara et al.	75	232	
	AC	5,486,491	01-1996	Sengupta	501	137	
Z	AD	6,478,902 B2	11-2002	Koenigsmann et al.	148	681	
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Subclass	Translation
Z	AL	11323539	11-1999	Japan	←	→	abstract
Z	AM	0441408A2	08-1991	EPO	←	→	
	AN						
	AO						
	AP						
<b>OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)</b>							
Z	AR	Yeon et al., "Electrical Characteristics of the MOD-derived SrBi <sub>2</sub> Ta <sub>2</sub> O <sub>9</sub> and SrBi <sub>2.4</sub> (Ta,Nb)O <sub>9</sub> Thin Films", Journal of Materials Science, 35(10), pgs. 2405-2411, May 15, 2000. Abstract only.					
Z	AS	Yan et al., "Preparation on the [(Pb,La) (Zr,Ti)O <sub>3</sub> ] Ferroelectric Thin Films by Using the Sol-Gel Processing", Piezoelectrics and Acoustooptics, Volume 17, issue n 5, October 1995, pgs. 24-27.					
	AT						
EXAMINER			DATE CONSIDERED		6/14/03		
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